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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 09/360,292
Filing Date July 22, 1999
Inventor Sujit Sharan et al.
Assignee Micron Technology, Inc.
Group Art Unit 1746
Examiner Shamim Ahmed
Attorney's Docket No. M12271106
Title: Plasma Etching Process

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 CFR § 1.56. Copies of the cited art are included herewith. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated:

July 2, 2003

By:

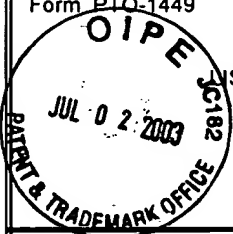
Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711

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| Form PTO-1449 | | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | ATTY. DOCKET NO. MI22-1106 | | SERIAL NO. 09/360,292 | |
|  LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) | | | | APPLICANT: Sujit Sharan et al. | | | |
| | | | | FILING DATE July 22, 1999 | | GROUP 1746 | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| *Examiner Initial | Document Number | Date | Name | Class | Subclass | Filing Date If Appropriate | |
| | AA | 6,051,503 | 04-2000 | Bhardwaj et al. | | | |
| | AB | 5,880,005 | 03-1999 | Tsai et al. | | | |
| | AC | | | | | | |
| | AD | | | | | | |
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| FOREIGN PATENT DOCUMENTS | | | | | | | |
| | | Document Number | Date | Country | Class | Subclass | Translation |
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| | AL | | | | | | |
| | AM | | | | | | |
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| OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | |
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| EXAMINER | | | | DATE CONSIDERED | | | |
| *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | | | | | | | |

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